



X-ray flourescence setup and measurements of CMOS sensors

31st RD 50 Workshop CERN

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Susanne-Kuehn CERN,

Enrico Junior Schioppa CERN, Felipe Oliveira Brazilian Synchrotron Light Laboratory, Michael Kaemingk New Mexico State University, Christian Riegel CERN/University of Wuppertal

Sensor design@CERN: Thanushan Kugathasan, Cesar Augusto Marin Tobon, Heinz Pernegger, Petra Riedler, Walter Snoeys, Jacobus Willem Van Hoorne

Outline

CERN

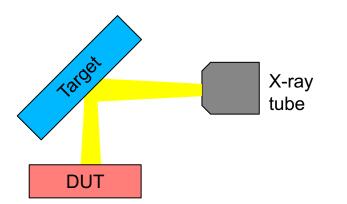
- Idea of x-ray fluorescence measurements
- Details on the setup
- Details on the CMOS TowerJazz Investigator chip
- Measurements
- Summary

X-ray fluorescence method

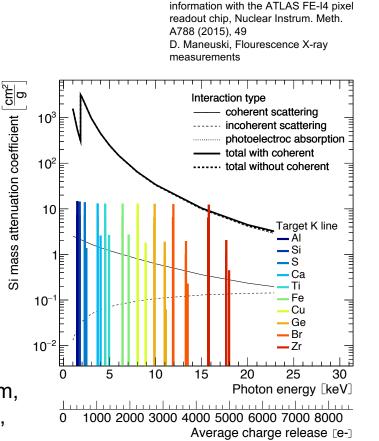
Many new pixel CMOS sensors to evaluate

Method to calibrate and study the linearity of response of new sensors in the lab

- \rightarrow X-ray fluorescence method
- X-ray from tube induces K_α- and K_β emission lines of target materials and gives access to a dense set of **monochromatic** lines in the keV-100 keV range measurements



- Typical target materials: Al, Tin, Titanium, Molybdenum, Zinc, Manganese, Iron, Copper, Gemanium, Zirconium,
- Plus allows measurements of charge spectra and energy resolution



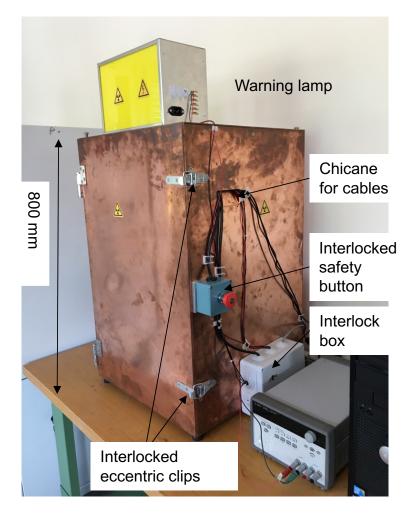
Courtesy: E. Jr. Schioppa

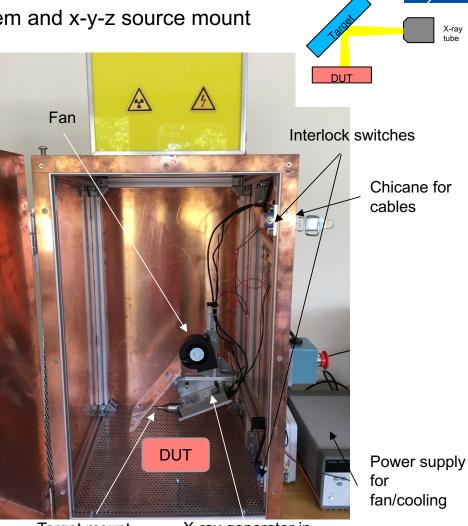


L.-D. Pohl et al., Obtaining spectroscopic

X-ray fluorescence setup at CERN

4 mm thick copper wall box with interlock system and x-y-z source mount





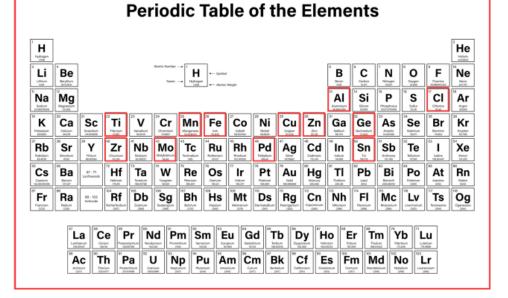
Target mount with target

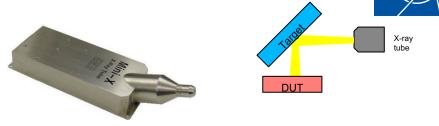
X-ray generator in mount, movable in x,z,y

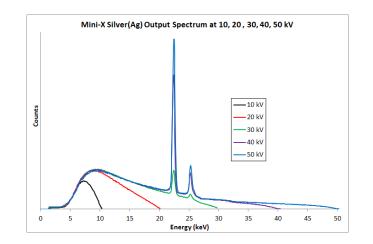
With support from L. Tluosos, J. Alozy, M. Abbas and CERN EP-DT-EO

X-ray fluorescence setup at CERN ctd'

- Portable X-ray source: AMPTEK Mini-X with Ag transmission target
 - Max. 4 W (HV:10 kV to 50 kV, current: 5 μA to 200 μA), controlled via USB
 - 10⁶ counts per s/mm² (30 cm distance)
- Target materials: potentially two calibration energies per target







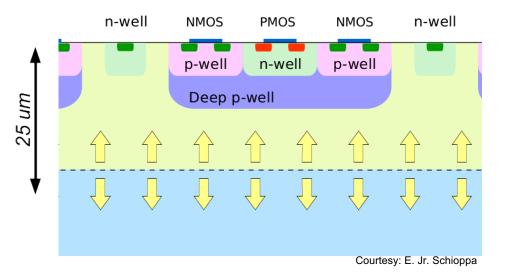
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Flourescence setup and measurements - Susanne Kuehn

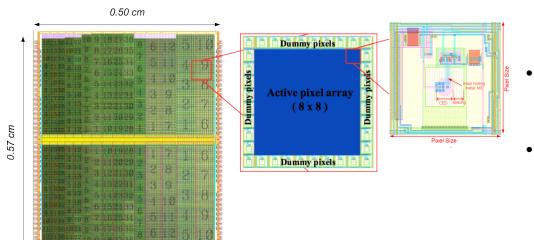
CMOS Sensor: TowerJazz 180nm technology



• The modified process with high efficiency after irradiation



• TowerJazz Investigator 1 chip



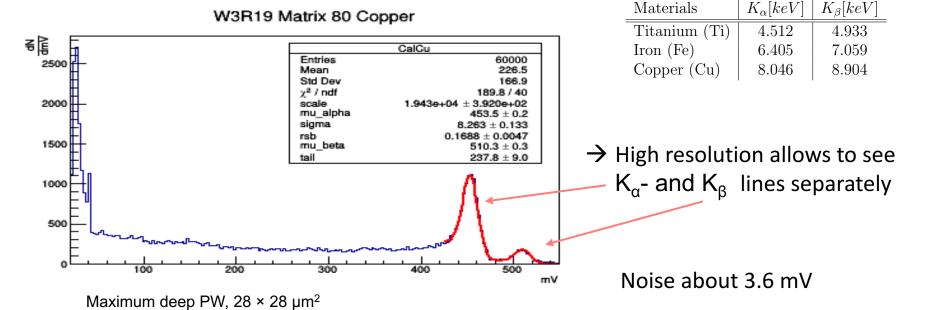
- Low input capacitance (~fF) at the collection electrode
- Large S/N ratio can be achieved
- Fast signals
- A planar junction extends across the full pixel surface
- Charge collected in depleted volume

H. Pernegger et al., First tests of a novel radiation hard cmos sensor process for depleted monolithic active pixel sensors, JINST 12 (2017) P06008

- Many different mini-matrices differing in geometry & front-end
- 4 matrices measured with pixel size of 28 × 28 µm² and 30 × 30 µm² and different depth of p-well

Measurements

- Test of 4 matrices with 3 target materials (unirradiated)
- Bias voltage 6 V
- Single pixel read out with Cividec C2HV amplifier, pulse amplitude proportional to charge
- 60000 events for each of the matrices for each of the target materials and wave-forms fitted
- → Charge spectra from X-ray emission

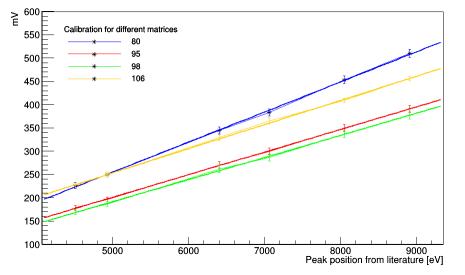




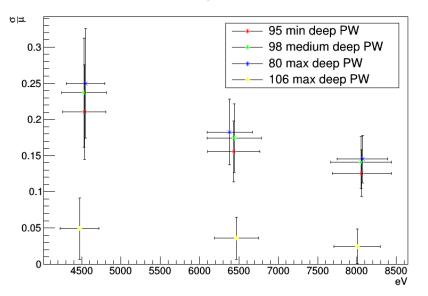
Results of unirradiated chip

CERN

Gamma peak positions versus literature values



Energy resolution for K_α-energies



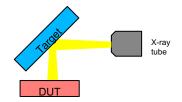
- Matrix 80 (maximum deep PW),
- Matrix 95 (minimum deep PW) and
- Matrix 98 (medium deep PW) with 28 × 28 µm²
- Matrix 106 (maximum deep PW) with 30
 × 30 μm²
- Linearity of gain
- Slightly higher gain for matrix 80 and also matrix 108 with maximum deep P-well

- Matrix 106 with larger pixel size has a better energy resolution (around 0.05 ± 0.04)
- Matrix 80 with maximum deep PW around 0.25 ± 0.08

Summary

CERN

- X-ray flourescence setup installed and commissioned at CERN
- Ready to be used with new sensors
- Unirradiated CMOS Sensor Matrices from TowerJazz Investigator1 chip characterized with three target materials
 - Linear gain and good energy resolution measured
 - Matrix 80 has a higher gain (0.065 ± 0.002)
 - Matrix 106 has a better energy resolution (0.05 ± 0.04)
 - Low noise in the setup
- More measurements with several target materials ongoing
- Upgrade of setup for irradiated sensors in preparation





Thanky you!

Thank you to Enrico and the Summer students Felipe and Michael!

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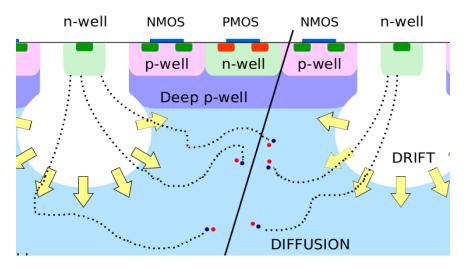
Spare



TowerJazz 180nm CMOS technology



• The standard process



Difficult to obtain full lateral depletion Not radiation hard